

DE 3 - 30464

IEC SYSTEM FOR MUTUAL RECOGNITION OF TEST CERTIFICATES FOR ELECTRICAL EQUIPMENT (IECEE) **CB SCHEME**

SYSTEME CEI D'ACCEPTATION MUTUELLE DE CERTIFICATS D'ESSAIS DES EQUIPEMENTS ELECTRIQUES (IECEE) METHODE OC

CB TEST CERTIFICATE CERTIFICAT D'ESSAI OC

Product

Name and address of the applicant

Name and address of the manufacturer

Name and address of the factory

Ratings and principal characteristics

Laboratory equipment (microscope system)

Leica Microsystems CMS GmbH

Ernst-Leitz-Straße 17-37 35578 Wetzlar, GERMANY

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WSU

Rated voltage:

100-240 V

Rated frequency:

50/60 Hz 250 VA

Rated power: Protection class:

Supply Unit Scanhead (supplied Infinity Scanner) Rated voltage:

100-240 V

Rated frequency:

50/60 Hz

Rated power:

150 VA

Protection class:

Pulsed Laser Unit 355 nm (Ablation laser)

Rated voltage

12 VDC (supplied via external

limited power supply unit)

Protection class:

Laser class:

Protection class:

Leica

CTF Stage 1

The microscope system consists of: WSU, Pulsed Laser Unit 355 nm, Infinity scanner, Supply Unit Scanhead

Additional information (if necessary)

Trade mark (if any)

Model/type Ref.

A sample of the product was tested and found to be in conformity with

Customer's Testing Facility (CTF) Stage used

as shown in the Test Report Ref. No. which forms part of this certificate

IEC 61010-1:2010 IEC 60825-1:2014

028-713099377-000

This CB Test Certificate is issued by the National Certification Body Ce Certificat d'essai OC est établi par l'Organisme National de Certification

Date,

2017-06-01

CB 17 05 56257 160

Tises

Ralph Fischer

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Product Service